

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/699,157	TANAKA ET AL.	
Examiner	Art Unit	
Kin-Chan Chen	1765	

SEARCHED						
Class	Subclass	Date		Examiner		
438	706	10/28/2005		10/28/2005 KC		cc
	710					
	714					
	7/2					
	723					
438	725					
438	637		•			
438	638	10/2	8/05	K	cc	

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East Kywoods servel USPAT. USPG-Pub. EPO, JPO, Derwent IBM- TDB, Inventor serv	10/28/2005	ксс		
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